



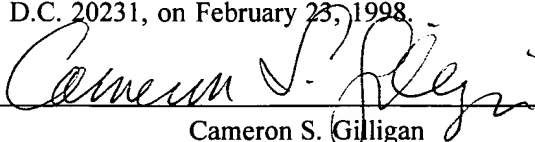
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Docket: 0756-1614

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3-9-98  
M. Ross

# CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on February 23, 1998.

  
Cameron S. Gilligan

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Takeshi FUKUNAGA et al. )  
Serial No. 08/781,920 ) Art Unit: 1112  
Filed: December 30, 1996 ) Examiner: M. Padgett  
For: METHOD OF MANUFACTURING )  
A SEMICONDUCTOR DEVICE )

## AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 21, 1997, please amend the subject application as follows.

## IN THE TITLE:

Please replace the Title with the following:

--METHOD OF FABRICATING A SEMICONDUCTOR DEVICE  
UTILIZING A CATALYST MATERIAL SOLUTION--

## IN THE CLAIMS:

Please cancel claims 1-4, 6-15 and 7-23.